



P/3241-18

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Masamichi Fujiwara et al.

Date: July 8, 2004

Serial No.: 09/900,613

Group Art Unit: 2874

Filed: July 6, 2001

Examiner: John D. Lee

For: MULTI-WAVELENGTH GENERATING METHOD AND APPARATUS
BASED ON FLATTENING OF OPTICAL SPECTRUM

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

Applicants note that the U.S. equivalent of Japanese Publication No. 08-313852 is U.S. Patent No. 5,566,381 and the U.S. equivalent of Japanese Publication No. 02-269309 is U.S. Patent No. 5,074,631. Copies are enclosed.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in two counterpart foreign applications not more than 3 months prior to the filing of this Submission.

I respectfully request that the information submitted be considered and enclose our check number 17400 in payment of the required \$180.00 fee.

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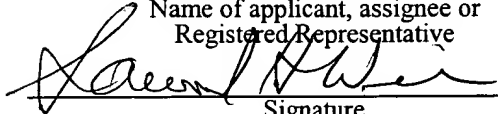
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In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

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Samuel H. Weiner

Name of applicant, assignee or
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Signature

July 8, 2004

Date of Signature

Respectfully submitted,



Samuel H. Weiner

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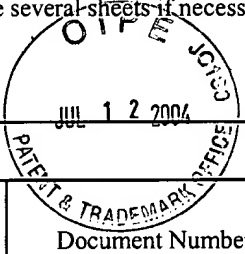
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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 09/900,613		OFGS File No. P/3241-18	
		Applicant Masamichi Fujiwara et al.			
		Filing Date July 6, 2001		Group Art Unit 2874	



U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-5,074,631	12-1991	Hamano et al.			
	US-5,566,381	10-1996	Korotky			
	US-					
	US-					
	US-					
	US-					
	US-					
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	02-269309	11-1990	Japan			X (Abstract)	
	04-014010	01-1992	Japan			X (Abstract)	
	08-313852	11-1996	Japan			X (Abstract)	
	11-103288	04-1999	Japan			X	
	2000-19470	01-2000	Japan			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner	Date Considered
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.